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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of:

Hidefumi NAKATA

Date: March 4, 2002

Serial No.: 09/989,962

Group Art Unit: ----

Filed: February 26, 1999

Examiner: -----

COPY OF PAPERS  
ORIGINALLY FILEDFor: **MIM CAPACITOR AND MANUFACTURING METHOD THEREFOR**

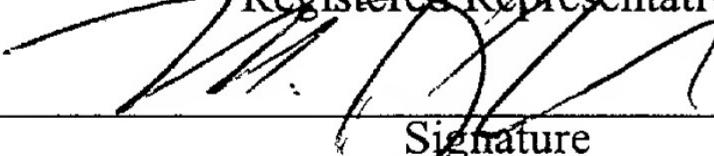
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Assistant Commissioner for Patents  
Washington, DC 20231**Attention: Official Draftsperson****FORMAL DRAWINGS**

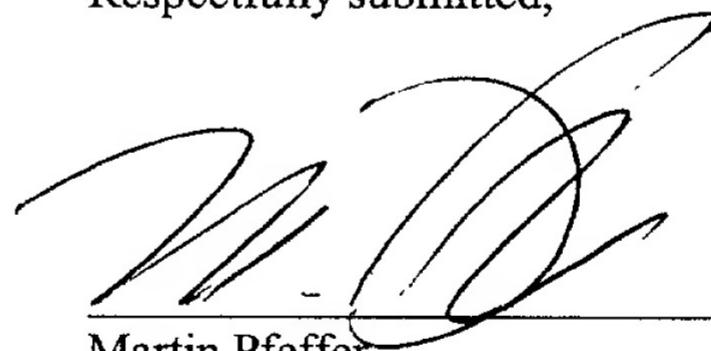
Sir:

Enclosed herewith please find three (3) sheets of formal drawings containing Figures 1-4D for the above-identified application.

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on March 4, 2002:

Martin Pfeffer  
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Registered Representative  
  
Signature  
March 4, 2002  
Date of Signature

Respectfully submitted,



Martin Pfeffer  
Registration No.: 20,808  
OSTROLENK, FABER, GERB & SOFFEN, LLP  
1180 Avenue of the Americas  
New York, New York 10036-8403  
Telephone: (212) 382-0700

MP:jy  
Enclosures